

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

In re the Application of

Makoto KOBAYASHI et al.

Application No.: 09/830,434

Filed: April 26, 2001

For: POLISHING PAD AND POLISHING METHOD FOR SEMI-CONDUCTOR WAFER



Group Art Unit: 3723

Examiner: H. Shakeri

Docket No.: 109352

**NOTICE OF APPEAL TO THE BOARD OF
PATENT APPEALS AND INTERFERENCES**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED

FEB 23 2004

TECHNOLOGY CENTER R3700

Sir:

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the Decision of the Primary Examiner dated November 21, 2003.

The \$330.00 Appeal Fee (\$165.00 Small Entity) is:

X Enclosed (our Check No. 151184)

Not required (fee paid in prior appeal in this application with no Board Decision on the merits).

The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 15-0461. Two duplicate copies of this document are enclosed.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Christopher W. Brown
Registration No. 38,025

WPB:CWB/rav
Date: February 19, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

02/20/2004 SSANDARA 00000019 09830434

01 FC:1401

330.00 OP